

Notice of References Cited

Application/Control No.

10/053,760

Applicant(s)/Patent Under
Reexamination
PODILA ET AL.

Examiner

Hong C Kim

Art Unit

2186

Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2003/0093487 ✓	05-2003	Czajkowski et al.	709/213
	B	US-2002/0129172 ✓	09-2002	Baskey et al.	709/310
	C	US-2002/0129085 ✓	09-2002	Kubala et al.	709/104
	D	US-2001/0047512 ✓	11-2001	Szewerenko et al.	717/10
	E	US-6,629,153 ✓	09-2003	Gupta et al.	719/316
	F	US-6,601,146 ✓	07-2003	Auslander et al.	711/147
	G	US-5,787,300 ✓	07-1998	Wijaya, Joyo	712/1
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	WO 200013085 A1 ✓	03-2000	World Intellect	BUNCE et al.	G06F 09/46
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.

ldh

Tle